

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Kwang-hee Lee et al.

Serial No.: 10/801,208

Filed: March 16, 2004

For: METHODS OF MANUFACTURING SEMICONDUCTOR DEVICES HAVING A RUTHENIUM LAYER VIA AUTOMATIC LAYER DEPOSITION

Date: July 12, 2007

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Sir:

Applicants submit the present *Amendment* in response to the Office Action mailed April 18, 2007.

It is not believed that an extension of time and/or additional fee(s) -- including fees for net addition of claims -- are required, beyond those that may otherwise be provided for in documents accompanying this paper. In the event, however, that an extension of time is necessary to allow consideration of this paper, such an extension is hereby petitioned under 37 C.F.R. §1.136(a). Any additional fees believed to be due in connection with this paper may be charged to our Deposit Account No. 50-0220.